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|--|---|-----------------------------|---|---|
| SERIAL NUMBER 10/802,836 | FILING OR 371(c) DATE 03/18/2004 RULE | CLASS 430 | GROUP ART UNIT 1722 | ATTORNEY DOCKET NO. 250490US2 |
| APPLICANTS Yukio Taniguchi, Yokohama-shi, JAPAN; Masakiyo Matsumura, Yokohama-shi, JAPAN; | | | | |
| ** CONTINUING DATA ***** | | | | |
| ** FOREIGN APPLICATIONS ***** JAPAN 2003-089545 03/28/2003 | | | | |
| IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 05/31/2004 | | | | |
| Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged _____ Examiner's Signature _____ Initials _____ | STATE OR COUNTRY JAPAN | SHEETS DRAWING 11 | TOTAL CLAIMS 11 | INDEPENDENT CLAIMS 4 |
| ADDRESS 22850 | | | | |
| TITLE Method and apparatus for forming crystalline portions of semiconductor film | | | | |
| FILING FEE RECEIVED 1146 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit | |